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Freeform Search

Database:	US Pre-Grant Publication Full-Text Database US Patents Full-Text Database US OCR Full-Text Database EPO Abstracts Database JPO Abstracts Database Derwent World Patents Index IBM Technical Disclosure Bulletins				
Term:	L40 and @ad<20010102				
Display: Generate:	Documents in Display Format: - Starting with Number 1 C Hit List Hit Count Side by Side Image Search Clear Interrupt	**************************************			
Search History					

DATE: Tuesday, July 13, 2004 Printable Copy Create Case

Set Name side by side	Query	<u>Hit</u> <u>Count</u>	Set Name result set	
DB=PGPB, $USPT$, $USOC$, $EPAB$, $JPAB$, $DWPI$, $TDBD$; $PLUR=YES$; $OP=OR$				
<u>L41</u>	L40 and @ad<20010102	79	<u>L41</u>	
<u>L40</u>	L39 and 130	149	<u>L40</u>	
<u>L39</u>	L38 with (laser\$1 or beam\$1)	397	<u>L39</u>	
<u>L38</u>	((chang\$6 or caus\$4) near5 (refractive or refraction or phase)) with (glass or quartz)	4151	<u>L38</u>	
<u>L37</u>	L35 and @ad<20010102	7	<u>L37</u>	
<u>L36</u>	L35	22	<u>L36</u>	
<u>L35</u>	L32 with (glass or quartz)	22	<u>L35</u>	
<u>L34</u>	L31 and @ad<20010102	93	<u>L34</u>	
<u>L33</u>	L32 and 123	7	<u>L33</u>	
<u>L32</u>	((chang\$6 or caus\$4) near5 (refractive or refraction or phase)) with 130	549	<u>L32</u>	
<u>L31</u>	L30 same 128	188	<u>L31</u>	
<u>L30</u>	(short or ultrashort or fs or ps or picosec\$6 or femtosec\$6) near10 (laser\$1 or beam\$1)	120802	<u>L30</u>	
<u>L29</u>	(short or ultrashort or fs or ps or picosec\$6 or femtosec\$6) near10(laser\$1	120802	<u>L29</u>	

	or beam\$1)		
<u>L28</u>	(glass\$2 or quartz) with 121	4054	<u>L28</u>
<u>L27</u>	L26 and @ad<20010102	74	L27
<u>L26</u>	L23 same 121	108	<u>L26</u>
L25	L22 with l21	1278	<u>L25</u>
L24	L23 with l21	52	<u>L24</u>
<u>L23</u>	(glass\$2 or quartz or transparent or substrate\$1 or support\$1) near8 (phase near2 (mask\$1 or photomask\$1 or reticle\$1))	2529	<u>L23</u>
<u>L22</u>	(glass\$2 or quartz or transparent or substrate\$1 or support\$1) near5 (mask\$1 or photomask\$1 or reticle\$1)	89970	<u>L22</u>
<u>L21</u>	L20 near5 (laser\$1 or beam\$1)	177826	<u>L21</u>
<u>L20</u>	(etch\$4 or ablat\$4 or writ\$4 or remov\$4 or mark\$4 or damag\$4 or machin\$6)	8931254	<u>L20</u>
<u>L19</u>	L18 and @ad<20010102	162	<u>L19</u>
<u>L18</u>	L17 and 19	233	<u>L18</u>
<u>L17</u>	L13 with 16	1074	<u>L17</u>
<u>L16</u>	L15 and 16	622	<u>L16</u>
<u>L15</u>	L13 same 13	1027	<u>L15</u>
<u>L14</u>	L13 same 19	229	<u>L14</u>
<u>L13</u>	L5 near4 (phase)	11017	<u>L13</u>
<u>L12</u>	L5 near8 12	155368	<u>L12</u>
<u>L11</u>	L5 with 12	178250	<u>L11</u>
<u>L10</u>	L6 with 13	27322	<u>L10</u>
<u>L9</u>	L8 same 13	4076	<u>L9</u>
<u>L8</u>	L7 same 16	48005	<u>L8</u>
<u>L7</u>	L5 with (glass\$2 or quartz or transparent or substrate\$1 or support\$1)	144884	<u>L7</u>
<u>L6</u>	L2 near8 (glass\$2 or quartz or transparent or substrate\$1 or support\$1)	608713	<u>L6</u>
<u>L5</u>	(mask\$1 or photomask\$1 or reticle\$1)	482518	<u>L5</u>
<u>L4</u>	L2 with (glass\$2 or quartz or transparent or substrate\$1 or support\$1)	840760	<u>L4</u>
<u>L3</u>	L2 with (laser\$1 or beam\$1)	218350	<u>L3</u>
<u>L2</u>	(etch\$4 or ablat\$4 or writ\$4 or remov\$4 or mark\$4 or damag\$4 or ((chang\$5 or caus\$4) near5 (refractive or refraction or phase)))	7326076	<u>L2</u>
<u>L1</u>	(etch\$6 or ablat\$6 or writ\$4 or remov\$6 or mark\$4 or ((chang\$6 or caus\$4) near5 (refractive or refraction or phase)))	6785037	<u>L1</u>

END OF SEARCH HISTORY